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Notice of Allowability	Application No.	Applicant(s)	
	10/805,124	WANG ET AL.	
	Examiner	Art Unit	
	Hsien-ming Lee	2823	
Th MAILING DATE of this communication apperall claims being allowable, PROSECUTION ON THE MERITS IS herewith (or previously mailed), a Notice of Allowance (PTOL-85) NOTICE OF ALLOWABILITY IS NOT A GRANT OF PATENT RIOF of the Office or upon petition by the applicant. See 37 CFR 1.313	(OR REMAINS) CLOSED in this ap or other appropriate communicatio GHTS. This application is subject	oplication. If not included n will be mailed in due course.	
1. This communication is responsive to 4/21/2006.			
2. \boxtimes The allowed claim(s) is/are <u>7-17 and 19</u> .			
 Acknowledgment is made of a claim for foreign priority una)	been received. been received in Application No		1 the
Applicant has THREE MONTHS FROM THE "MAILING DATE" noted below. Failure to timely comply will result in ABANDONM THIS THREE-MONTH PERIOD IS NOT EXTENDABLE.		complying with the requirement	nts
 A SUBSTITUTE OATH OR DECLARATION must be subm INFORMAL PATENT APPLICATION (PTO-152) which give 			OF
5. CORRECTED DRAWINGS (as "replacement sheets") mus	t be submitted.		
(a) including changes required by the Notice of Draftspers		-948) attached	
1) 🗌 hereto or 2) 🔲 to Paper No./Mail Date			
(b) including changes required by the attached Examiner's Paper No./Mail Date	s Amendment / Comment or in the	Office action of	
Identifying indicia such as the application number (see 37 CFR 1 each sheet. Replacement sheet(s) should be labeled as such in t			f
 DEPOSIT OF and/or INFORMATION about the depo- attached Examiner's comment regarding REQUIREMENT 	SIT OF BIOLOGICAL MATERIAL FOR THE DEPOSIT OF BIOLOGIC	must be submitted. Note the CAL MATERIAL.	
Attachment(s) 1. ☐ Notice of References Cited (PTO-892) 2. ☐ Notice of Draftperson's Patent Drawing Review (PTO-948) 3. ☐ Information Disclosure Statements (PTO-1449 or PTO/SB/0	6. ☐ Interview Summar Paper No./Mail Da	ate	
Paper No./Mail Date 4. Examiner's Comment Regarding Requirement for Deposit of Biological Material		HSIEN-MING LEE PRIMARY EXAMINED	·//
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DETAILED ACTION

Remarks

1. The objection and rejection, as set forth in the previous office action, have been withdrawn in response to applicant's amendment filed 4/21/2006.

Allowable Subject Matter

- 2. Claims 7-17 and 19 are allowed.
- 3. The following is an examiner's statement of reasons for allowance:

The prior art of record at least neither teaches nor suggests using first etch mask and a second etch mask, wherein the first etch mask covering portions of said first region and more than half of said second region and said second etch mask covering all of said first region and portions of said second region; and first etch mask and second etch mask overlap to form a broadened region along lines that cross between the first etch mask and second etch mask.

- 4. Any comments considered necessary by applicant must be submitted no later than the payment of the issue fee and, to avoid processing delays, should preferably accompany the issue fee. Such submissions should be clearly labeled "Comments on Statement of Reasons for Allowance."
- 5. Any inquiry concerning this communication or earlier communications from the examiner should be directed to Hsien-ming Lee whose telephone number is 571-272-1863. The examiner can normally be reached on Tuesday-Thursday $(7:30 \sim 6:00)$.

If attempts to reach the examiner by telephone are unsuccessful, the examiner's supervisor, Matthew Smith can be reached on 571-272-1907. The fax phone number for the organization where this application or proceeding is assigned is 571-273-8300.

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Information regarding the status of an application may be obtained from the Patent Application Information Retrieval (PAIR) system. Status information for published applications may be obtained from either Private PAIR or Public PAIR. Status information for unpublished applications is available through Private PAIR only. For more information about the PAIR system, see http://pair-direct.uspto.gov. Should you have questions on access to the Private PAIR system, contact the Electronic Business Center (EBC) at 866-217-9197 (toll-free). If you would like assistance from a USPTO Customer Service Representative or access to the automated information system, call 800-786-9199 (IN USA OR CANADA) or 571-272-1000.

Hsien-ming Lee Primary Examiner Art Unit 2823

June 1, 2006

HSIEN-MING LEE PRIMARY EXAMINED //66